

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Hiroyuki NAGASAKA

Application No.: New U.S. Patent Application

Filed: August 18, 2006

Docket No.: 128675

For: EXPOSURE METHOD, EXPOSURE APPARATUS, EXPOSURE SYSTEM AND
METHOD FOR MANUFACTURING DEVICE

PRELIMINARY AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Please consider the following:

Amendments to the Specification;

Amendments to the Claims as reflected in the listing of claims; and

Remarks.